

APPENDIX A

Metal film

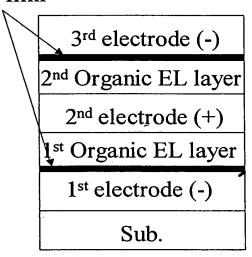


Fig. 1 The schematic structure showing organic EL device of the claimed invention

electrode (+)
HTL
EL layer
electrode (-)
EL layer
HTL
electrode (+)
Sub.

Fig. 2. The schematic structure showing organic EL device